



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

June 13, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG804636165

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

7.44 - 7.50 X 4.55 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

1.55 CARAT

F

VVS 1

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

EXCELLENT

NONE

IGI LG804636165

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

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Inscription(s)

EXCELLENT

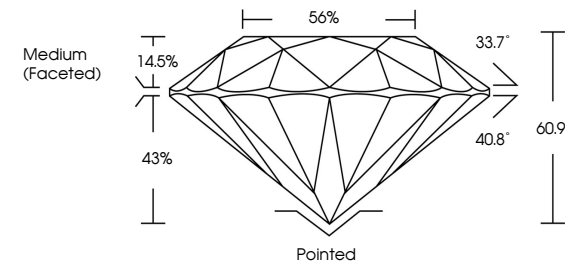
EXCELLENT

NONE

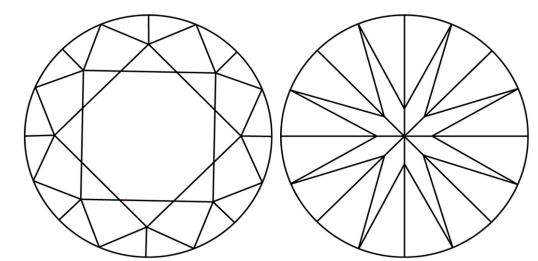
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PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Carat Weight

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Cut Grade

Depth

Table

Graile

1.55 CARAT

F

VVS 1

IDEAL

60.9%

86%

Medium (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG804636165

Culet

Polish

Symmetry

Fluorescence

Inscriptions(s)

None

EXCELLENT

EXCELLENT

NONE

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